

# APSPT 2009

## First Announcement and Call for Papers

**The Sixth Asia-Pacific International Symposium on the Basic and Application of Plasma Technology (APSPT-6)  
December 14-16, 2009 Hsinchu, Taiwan, R.O.C**

The sixth International Symposium on the Basic and Application of Plasma Technology will be held in Taiwan, R.O.C. on December 14-16, 2009. This conference plans to get together with Asia-Pacific area researchers from North and South America, East and South East Asia to establish cross link in the area of research in the plasma basic phenomena and industrial applications. The areas of focus for the symposium are:

1. Material processing
2. Surface treatments
3. Air pollution control
4. Solid and liquid waste treatment;
5. Light source and displays
6. Combustion control and reforming;
7. Bio and medical application of plasma
8. Control of plasma and new plasma sources
9. Basics and applications of atmospheric pressure plasma
10. Other advanced subjects and new applications of plasma

If you interested to attend this event, please submit title of paper or express of interest by e-mail, fax and mail by April 30, 2009 to the following address:

Prof. C.A. Wang (Secretary General of APSPT-6 Executive Committee)

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The second circulation will be sent to you upon this pre-registration. This conference is co-organized by the APSPT International Organizing Committee with Minghsin University of Science and Technology and co-supported by Chinese Institute of Plasma Engineering, National Science Council and Ministry of Education.



Main deadlines are as following:

Tentative title or pre-registration:

May 15, 2009

Abstract (200 words),

June 30, 2009

Full text (4 pages),

September 1, 2009

Registration Fees:

	Before Sept. 20, 2009	After Sept. 20, 2009
Regular:	US\$ 250 (NT\$ 8000)	US\$ 300 (NT\$ 10000)
Student (Full-time):	US\$ 80 (NT\$ 2500)	US\$ 100 (NT\$ 3000)

One workshop as the Post-Conference of APSPT-6 on the Atmospheric Pressure Plasma Application will be also arranged. Details will be followed in the second announcement.

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Committee of APSPT-6 Post-Conference Workshop

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